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SERIAL NUMBER 10/715,267	FILING DATE 11/17/2003  RULE	CLASS 156	GROUP ART UNIT 1763	ATTORNEY DOCKET NO. 2269-4375.1US (99-1029.01)
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## APPLICANTS

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## \*\* CONTINUING DATA \*\*\*\*\*

This application is a DIV of 09/912,982 07/25/2001 PAT 6,863,771

*dm*

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

*none dm*

## IF REQUIRED, FOREIGN FILING LICENSE GRANTED

\*\* 03/02/2004

Foreign Priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no	STATE OR	SHEETS	TOTAL	INDEPENDENT
35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after	COUNTRY	DRAWING	CLAIMS	CLAIMS
Verified and Acknowledged <i>mu</i> Allowance Examiner's Signature <i>dm</i> Initials	TX	7	31	2

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## TITLE

Methods for polishing semiconductor device structures by differentially applying pressure to substrates that carry the semiconductor device structures

FILING FEE  RECEIVED 968	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue )
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